



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Ravi Iyer

Serial No.: 09/059,865

Filed: April 14, 1998

For: PLANARIZATION USING PLASMA
OXIDIZED AMORPHOUS SILICON

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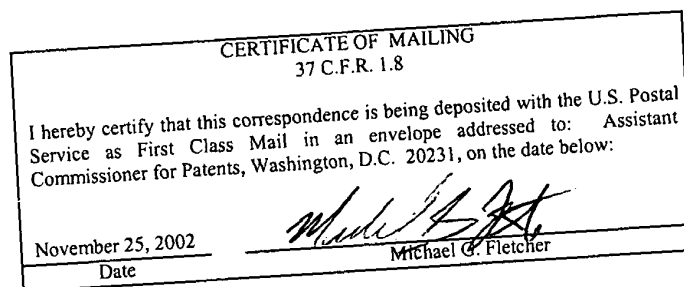
Group Art Unit: 2813

Examiner: Nguyen, T.

Atty Docket: MICS:0015--2/FEE
93-118.02

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Assistant Commissioner
for Patents
Washington, D.C. 20231



Sir:

SUPPLEMENT TO REQUEST FOR REHEARING UNDER 37 C.F.R. § 1.197(b)

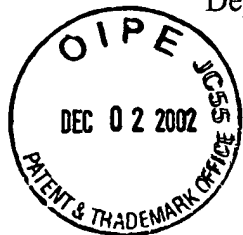
In response to the Decision on Appeal mailed on September 25, 2002, for the above-referenced application, Appellant respectfully requests rehearing of the Board's Decision in view of the remarks set forth below.

In the Request For Rehearing Under 37 C.F.R. § 1.197(b) filed on this date, Appellant failed to address the rejection under obviousness-type double patenting. As previously offered by Appellant, please find attached a properly executed Terminating Disclaimer to obviate the outstanding rejection.

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The Commissioner is authorized to charge any fees which may be required to

Deposit Account No. 13-3092; Order No. MICS:0015--2/FLE (93-118.02).



Respectfully submitted,

Date: November 25, 2002

Michael G. Fletcher
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